

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/701,824	CHANG ET AL.
	Examiner	Art Unit
	Hsien-ming Lee	2823

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	48,444	9/1/5	Lei
257	618	↓	↓
438	14,16	↓	↓
438			